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PATENT APPLICATION

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Date February 9, 2004

Corres. and Mail  
**BOX AF**

In re the Application of

Kazuo ICHIKAWA et al.

Group Art Unit: 1763

Application No.: 09/670,877

Examiner: R. Zervigon

Filed: September 27, 2000

Docket No.: 107469

For: CVD SUBSTRATE AND CLEANING METHOD

**LARGE ENTITY PETITION FOR 1<sup>st</sup> - 3<sup>rd</sup> EXTENSION  
OF TIME UNDER 37 C.F.R. §1.136(a) AND  
TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17**

RECEIVED  
FEB 19 2004

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is a response to the outstanding Official Action in the above-identified patent application. The shortened statutory period having expired January 7, 2004, an extension of time for a period of ONE month is hereby requested. Attached hereto is our Check No. 150828 in the amount of \$110.00 in payment for:

XX Extension fee for response within first month pursuant to §1.136(a) (\$110.00)  
\_\_\_\_\_ Extension fee for response within second month pursuant to §1.136(a) (\$420.00)  
\_\_\_\_\_ Extension fee for response within third month pursuant to §1.136(a) (\$950.00)

The Commissioner is hereby authorized to charge any additional fee or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two copies of this petition are enclosed.

Respectfully submitted,

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JAO:SSK/jfb

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DEPOSIT ACCOUNT USE  
AUTHORIZATION  
Please grant any extension  
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02/10/2004 SSESHE1 00000107 09670877 110.00 0P  
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